

		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M22-1894		SERIAL NO. 0686383	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					
		APPLICANT Richard H. Schuler et al.				FILING DATE June 15, 2001	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KWD	AA 6,518,122	03/03	Chen, et al	438	257		
KWD	AB 6,492,688	12/02	Ug (LUG)	257	369		
KWD	AC 6,373,154	04/02	Jiang, et al	257	413		
KWD	AD 3,904,001,868	09/01	Corcoran, et al	438	275		
KWD	AE 6,583,815 B1	01/03	Jiang	438	584		
KWD	AF 6,485,061 B1	11/02	Xia, et al	438	680		
KWD	AG 6,486,027 B1	11/02	Yeh, et al	438	633		
KWD	AH 6,485,372 B1	10/02	Xia, et al	438	787		
KWD	AI 6,444,593 B1	09/02	Ngo, et al	438	788		
KWD	AJ 6,438,888 B1	06/02	Ngo, et al	438	623		
KWD	AK 6,435,943 B1	06/02	Chang, et al	451	28		
KWD	AL 6,429,115 B1	05/02	Tsai, et al	438	622		
KWD	AM 6,284,677 B1	04/04	Hsiao, et al	438	783		
KWD	AN 6,033,903	03/04	Hopper, et al	438	711		
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
KWD	AM 9045186	01/06	JP	—	—	abstract	
KWD	AN 9045188	01/06	JP	—	—	abstract	
KWD	AO 7260736	08/05	JP	—	—	abstract	
KWD	AP 9322113	08/04	JP	—	—	abstract	
OTHER REFERENCES (including Author, Title, Date, Periodic Page, Etc.)							
KWD	AR	Wol: S. "Silicon Processing for the VLSI Era" Vol. 1, pgs. 403-413.					
KWD	AS	Wol: S. "Silicon Processing for the VLSI Era" Vol. 2, pgs. 48-49 and 415.					
EXAMINER K. Duda				DATE CONSIDERED 2-19-04			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 606. Draw line through citation if not in conformance and not considered. Include copy of this form with any communications to applicant.							

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. M127-0402		SERIAL NO. 90881285	
<div style="display: flex; justify-content: space-between;"> <div style="border: 1px solid black; border-radius: 50%; padding: 10px; text-align: center;"> RECEIVED JAN 13 2004 U.S. DEPT. OF COMMERCE PATENT & TRADEMARK OFFICE </div> <div> LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) </div> </div>							
APPLICANT Richard Hatcher et al.				FILING DATE June 18, 2001		GROUP 136	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KUD	AA 6,123,615	2000	Strimer	257	646		
KUD	AB 5,964,217	11/99	Ng	438	636		
KUD	AC 5,685,519	10/99	Kakunuma et al.	430	313		
KUD	AD 5,347,395	03/98	Kaneko et al.	438	723		
KUD	AE 5,639,667	06/97	Russo et al.	438	69		
KUD	AF 5,495,535	05/96	Lin	438	302		
KUD	AG 20010001864	06/01	Oliva	438	687		
KUD	AH 20010041331	06/01	Cheng et al.	438	704		
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM						
	AN						
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Perform Pages, Etc.)							
	AR						
	AS						
EXAMINER K Duda				DATE CONSIDERED 2-19-04			
<small>*EXAMINER: Initial all references considered, whether or not identical to the invention with MPET 505. Draw line through citation if not in compliance and not considered. Include copy of this form with next communication to applicant.</small>							